

Emission Factors 101

Intel

February, 2006

What Role do Emission Factors Play?

What is an emission factor?

• "An emissions factor is a representative value that attempts to relate the quantity of a pollutant released to the atmosphere with an activity associated with the release of that pollutant." http://www.epa.gov/ttn/chief/ap42/index.html

Emission factors have been used by EPA since EPA's beginning as a way to estimate emissions and have been an integral part of their program

CHIEF is EPA's overall compilation of emission factors in various areas

• CHIEF stands for "Clearinghouse for Inventories and Emission Factors" -http://www.epa.gov/ttn/chief/efpac/index.html

Early emission factors were primarily for traditional heavy industries and combustion devices like boilers and generators

In the 1990s EPA attempted to expand the emission factor program to cover more industries

- Intel integral to developing semiconductor emission factors
- Only one EPA emission factor document specific to semiconductor manufacturing http://www.epa.gov/ttn/chief/eiip/techreport/volume02/ii06.pdf



Emission Factors and Intel

Intel NM permit requires quarterly reporting of:

- Nitrogen dioxide (NOx)
- Carbon monoxide (CO)
- Volatile organic compounds (VOCs)
- Hazardous air pollutants (HAPs)
- Toxic Air Pollutants (TAPs)
- Total suspended particulates (TSP) from hexamethyldisilizane (HMDS)

Methods to calculate emissions set in permit

Use:





Source of Emissions	Emissions	Source of Emissions Factors?
Combustion Sources (Boilers, Thermal Oxidizers, Emergency Generators)	NOx/CO	 On-site emissions testing and operational data
		 Manufacture's data for emergency generators
	SO2, TSP/PM10, VOC	Manufacture's data and EPA AP-42 emission factors
Manufacturing Process (exhausted to scrubbers and thermal oxidizers)	VOCs/HAPs	 Tool testing and process recipes
		EPA sink equation
		• No emission factors, ie. chemical use =
	VOCs/HAPs – untreated emissions	61115510115
		•No emissions factors, i.e. chemical use =
	TAPs	emissions
		•EPA sink equation
Tanks	VOCs/HAPs	•EPA tank equation



Boiler Emission Factors NOx/CO

Boilers

- Used for temperature and humidity control of factories
- Operate at 10 different lever positions similar to gears in a vehicle
- Primary fuel is natural gas diesel as back-up fuel

Permit requires annual update to emission factors – Condition C.ii.f details requirements

Emission factors based on 3 years operating and testing data:

- Average firing rate for each lever position
- Maximum stack testing data at each position

Permit requires annual compliance testing

- NMED typically observes
- NMED performed spot check with their equipment during 2004 inspection used to validate compliance testing



Thermal Oxidizer Emission Factors NOx/CO

Thermal Oxidizers

- Used to abate VOC emissions from factories
- Only run on natural gas
- Emission factors similar to boilers

Emission factors based on 2 years operating and testing data:

- Average firing rate
- Maximum stack testing data

NOx/CO stack testing data collected during quarterly compliance testing



HAP & VOC Emission Factors Example Calculation





HAP & VOC Emission Factors What information is used?

Chemical Use

- Each process has a specific recipe that is used for each step of the process
- Recipe specifies the amount of chemical used per wafer run

Tool Testing

- Emissions measured directly from the individual tool
- Airflow in the tool exhaust measured

How do we get a single emission factor for each chemical?

- For each chemical, the above information is gathered for every step and summed for all steps in the process to develop an overall emission factor
- This is done for every process run at Intel



HAP & VOC Emission Factors Chemical Use

Product lines developed in development factories

Defined process parameters for each step in manufacturing process

• Type(s) of chemical/gas, amount of chemical/gas, temperature, flow rate, etc.- set during development

Approval required for changes and modifications to manufacturing process

All changes are documented and tracked



HAP & VOC Emission Factors Tool Testing

Tools tested at development site as part of product development

Tools tested using an FTIR

 Documented protocol is used for testing http://www.sematech.org/docubase/document/4197axfr.pdf

Emissions verified at 1st high volume manufacturing site product is taken to

 Representative 12" process tools currently running in Fab 11X were tested Q2'04 (Robert S. from NMED observed testing)



Emission Factor Verification

External verification of all Intel emission factors

- Permit requires recordkeeping of all information used to calculate emissions
 - NMED reviews records during inspections
- Compliance Testing
 - Requirements set in permit
 - NMED typically observes

Internal verification for HAPs & VOC emission factors

- Peer environmental engineers from all Intel sites review all changes made to emission factors
- Verification testing done at 1st high volume manufacturing site product taken to
- Quarterly review of data from each site running process



NM Site Emissions Comparison Stack Emissions only 2005



FTIR Max - used detection limits to calculate emissions, detection limits vary each quarter, all VOCs non-detect expect for methanol for Fab 11X Fab RTO stack

FID Data - reported as lbs propane and converted to lbs VOCs by assuming average mix of largest VOC constituents



Summary

Emission factors used by Intel each quarter to calculate emissions

- Report submitted to NMED along with spreadsheets for their verification
 Emission factors based on EPA data or Intel operating and testing data
 Emissions verified
- Externally data submitted to NMED, stack testing
- Internally verification tool testing at manufacturing site, quarterly review of data



Additional Information



HAP & VOC Emission Factors Example Calculation

One process step uses 0.0025 lbs of Cl2 per wafer

Results in emissions of both Cl2 and HCl (formed as a byproduct)

Emissions testing on this step measured both of these pollutants and produced an average result of:

- 8.3x10-5 lbs of HCl per wafer
- 0.0018 lbs of Cl2 per wafer

The emission factor results would be:

- Cl2 to HCl EF = $(8.3 \times 10^{-5})/(0.0025) = 0.03$
- CI2 to CI2 EF = (0.0018)/(0.0025) = 0.72

In other words, every 100 lbs of Cl2 used will generate 3 lbs of HCl emissions and 72 lbs of Cl2 emissions

This type of information is then developed for every step which creates these emissions and an overall emission factor is developed

